IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Takashi OHSAKO et al.

Serial No. 10/677,221

Filed October 3, 2003

METHOD OF MANUFACTURING SEMICONDUCTOR ELEMENT

Confirmation No. 8585

Docket No. 2003 1364A

Group Art Unit 2823

Examiner Joannie Garcia

Mail Stop: Amendment

PETITION FOR EXTENSION OF TIME

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED TO CHARGE ANY DEFICIENCY IN THE FEES FOR THIS PAPER TO DEPOSIT ACCOUNT NO. 23-0975

Sir:

Petition hereby is made for a three month extension of time to respond to the communication of March 9, 2005.

The fee of \$1,020.00 is

- (X) submitted herewith.
- () to be charged to Deposit Account No. 23-0975. A duplicate copy of this Petition is enclosed.
- () Small entity status of this application is established by a Small Entity Status Assertion which
 - () is enclosed.
 - () has been previously submitted.

SEP 0 9 2005

Respectfully submitted,

09/12/2005 JADDO1 00000008 10677221

01 FC:1253

1020.00 UP

Takashi OHSAKO et

W. Douglas Hahm Registration No.44,142

Attorney for Applicants

WDH/ck Washington, D.C. 20006-1021 Telephone (202) 721-8200 Facsimile (202) 721-8250 September 9, 2005